IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Hiroki et al)
Serial No : 09/776,472)
Filed: February 2, 2001)
For: Thin Film Formation Apparatus And Method Of Manufacturing Self-Light-Emitting Device Using Thin Film Formation Apparatus))))
Art Unit: 1762)
Confirmation No.: 7144)
Evaminer: James Lin)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT (J)

Sir:

In response to the Final Rejection of August 8, 2006, a RCE being filed herewith, please amend the above-identified application as follows: